



DOCKET NO: VSEA 26-00


**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Steven R. Walther  
Serial No: 10/006,462  
Confirmation No: 5689  
Filed: December 4, 2001  
For: DOSE UNIFORMITY CONTROL FOR PLASMA DOPING  
SYSTEMS  
Examiner: Michelle Crowell  
Art Unit: 1763

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**CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)**

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Mail Stop RCE Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 4<sup>th</sup> day of August, 2006.

  
Janine Canillas

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Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:


**Petition for Three-Month Extension of Time**

A three-month extension of time, to and including August 6, 2006, is requested in response to the Examiner's Office Action of February 6, 2006.

Please charge the extension fee of \$1,020.00 to deposit account No. 50-0896. A duplicate of this Petition is enclosed.

Respectfully submitted,  
*Steven R. Walther, Applicant*

08/10/2006 MGE BREM1 00000022 500896 10006462  
02 FC:1253 1020.00 DA

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